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## APPLICANTS

David Boyd Rich, Kokomo, IN;

John C. Christenson, Kokomo, IN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/782,393 02/14/2001 PAT 6,685,844 *Hz*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *None*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY IN	SHEETS DRAWING 4	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>				

## ADDRESS

22851  
 DELPHI TECHNOLOGIES, INC.  
 M/C 480-410-202  
 PO BOX 5052  
 TROY, MI  
 48007

## TITLE

Deep reactive ion etching process and microelectromechanical devices formed thereby

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